

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jon Michael Kleinberg
ARC919970008US2

IBM Docket No.:

Serial No.: To be assigned

Group Art Unit:

Filed: Herewith

Examiner:


For: Method and System for Identifying Authoritative
Information Resources in An Enviromnent with
Content-Based Links Between Information Resources

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D. C. 20231

Sir:

In order to assist in the examination of this application, and in accordance with 37 CFR 1.56, 1.97 and 1.98, copies of the documents listed on the attached form PTO-1449 are forwarded herewith.

By: 
Timothy M. Farrell
Reg. No. 37,321
(914) 945-2756

IBM Corporation
Intellectual Property Law Dept.
P. O. Box 218
Yorktown Heights, New York 10598

FORM PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET NO. ARC919970008US2	SERIAL NO.
APPLICANT: Jon Michael Kleinberg		
(Use several sheets if necessary)	FILING DATE: Herewith	GROUP:

REFERENCE DESIGNATION		U.S. PATENT DOCUMENTS					
EXAMINER INITIALS		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPRO.)
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)	
AQ	CITATION INFLUENCE FOR JOURNAL AGGREGATES OF SCIENTIFIC PUBLICATIONS; THEORY, WITH APPLICATION TO THE LITERATURE OF PHYSICS; Gavriel Pinski and Frnacis Narin; Computer Horizons, Inc., 1050 Kings Highway North, Cherry Hill, NJ 08034, USA
AR	
AS	
AT	
AU	

EXAMINER	DATE CONSIDERED
----------	-----------------

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.